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INFORMATION DISCLOSURE CITATION
IN AN APPLICATION

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Document Number (Sequence)

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Application Number

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Applicant

Seiki Ogura et al.

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10/30/03

Group Art Unit

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILED DATE IF APPROPRIATE
IA	4943943	7/24/90	Hamashi et al.	365	185	7/24/84
IA	5768192	6/16/98	Eitan	365	185.24	7/23/96

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
IA	JP 11-22940	6/5/97	Japan	H01L	27/115		
IA	JP 00-31435	7/8/98	Japan	H01L	27/115		

OTHER DOCUMENTS (Including Author, Title, Date, Portmport Pages, Etc.)

IA	F. Masuoka et al., "A New NAND Cell for Ultra High Density SV-Only EEPROMs," May 1988, Proc. 1988 Symp. on VLSI Tech., IV-5, pp. 33-34.
IA	

EXAMINER

Ogura

DATE CONSIDERED

7/4/04

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.